

Supporting Information

1T MoS₂/CoS₂ Heterostructures Enabling Enhanced Resistive Switching Behavior in Sodium Alginate-based Flexible Memristors

Zipan Jiao^a, Xiaoyan Lan^a, Xinglan Zhou^a, Kunjie Wang^a, Haoran Zong^b, Peng Zhang^{a,*} and Benhua Xu^{b,*}

^a Qinghai Provincial Engineering Research Center of High-Performance Light Metal Alloys and Forming, Qinghai Provincial Key Laboratory of New Light Alloys, Qinghai University, Xining 810016, China

^b Chemical Engineering College, Qinghai University, Xining 810016, China

*Correspondence: zhangpeng@qhu.edu.cn (P. Zhang); xubenhua@qhu.edu.cn (B. H. Xu)

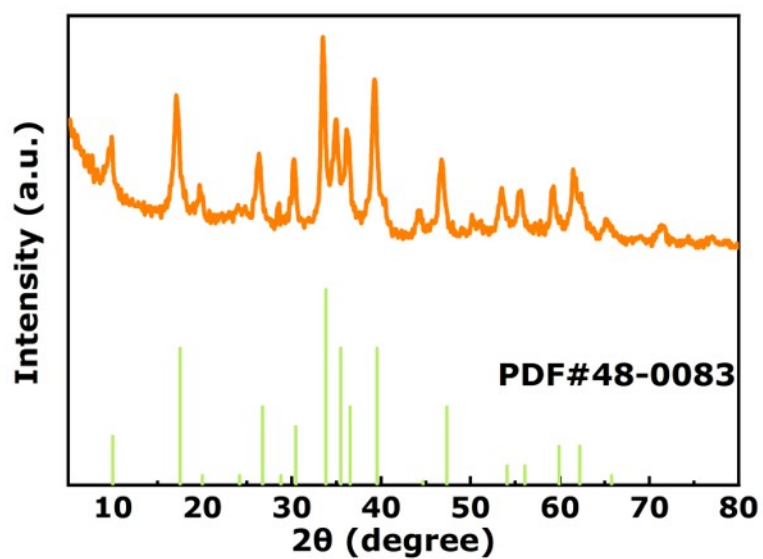


Fig. S1 XRD pattern of Co precursor.

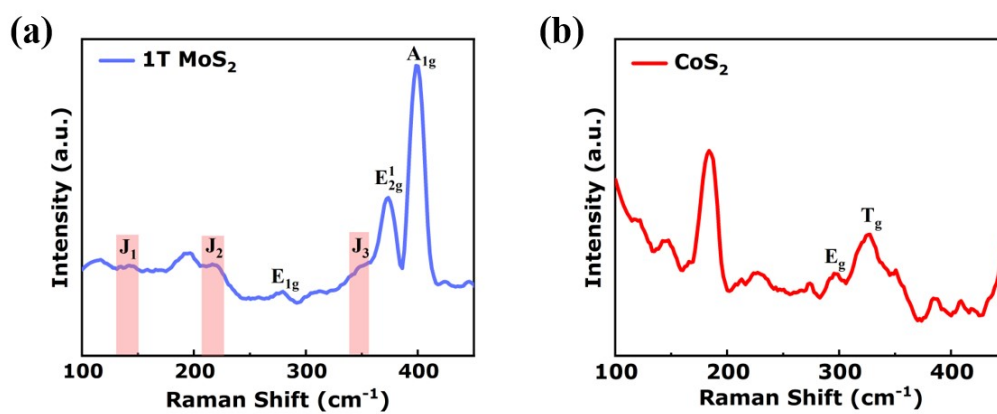


Fig. S2 (a) 1T MoS₂ nanosheets and (b) CoS₂ nanowires Raman spectra.

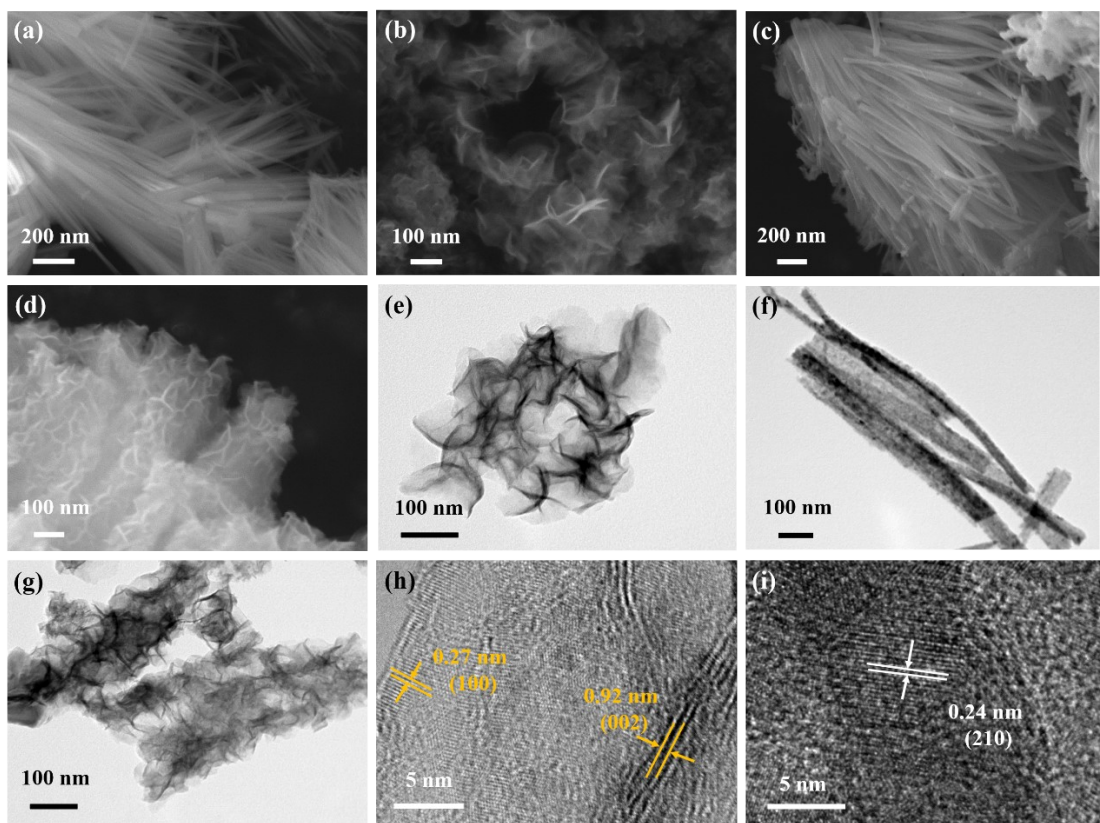


Fig. S3 (a-d) SEM images of Co precursor, 1T MoS₂ nanosheets, CoS₂ nanowires and 1T MoS₂/CoS₂ nanorods; (e-g) TEM images of 1T MoS₂ nanosheets, CoS₂ nanowires and 1T MoS₂/CoS₂ nanorods; (h-i) HRTEM images of 1T MoS₂ nanosheets and CoS₂ nanowires.

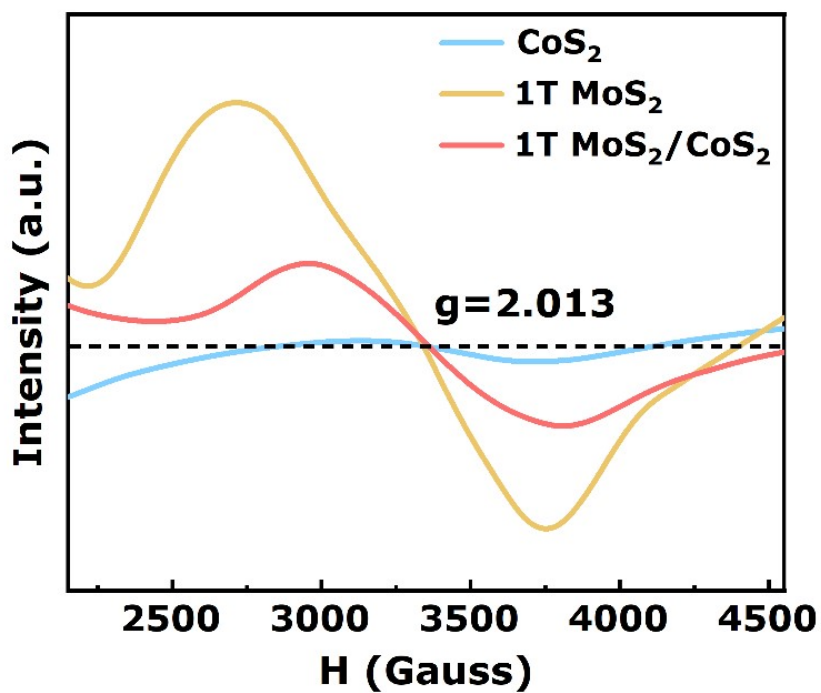


Fig. S4 EPR spectra of CoS₂ nanowires, 1T MoS₂ nanosheets and 1T MoS₂/CoS₂ nanorods.

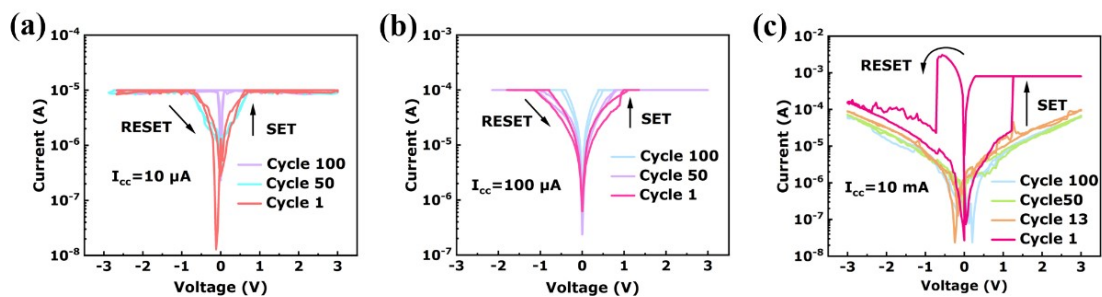


Fig. S5 The I-V curves of Al/1T MoS₂/CoS₂-SA/ITO/PET device with the compliance current is a) 10 μA; (b) 100 μA; c) 10 mA.

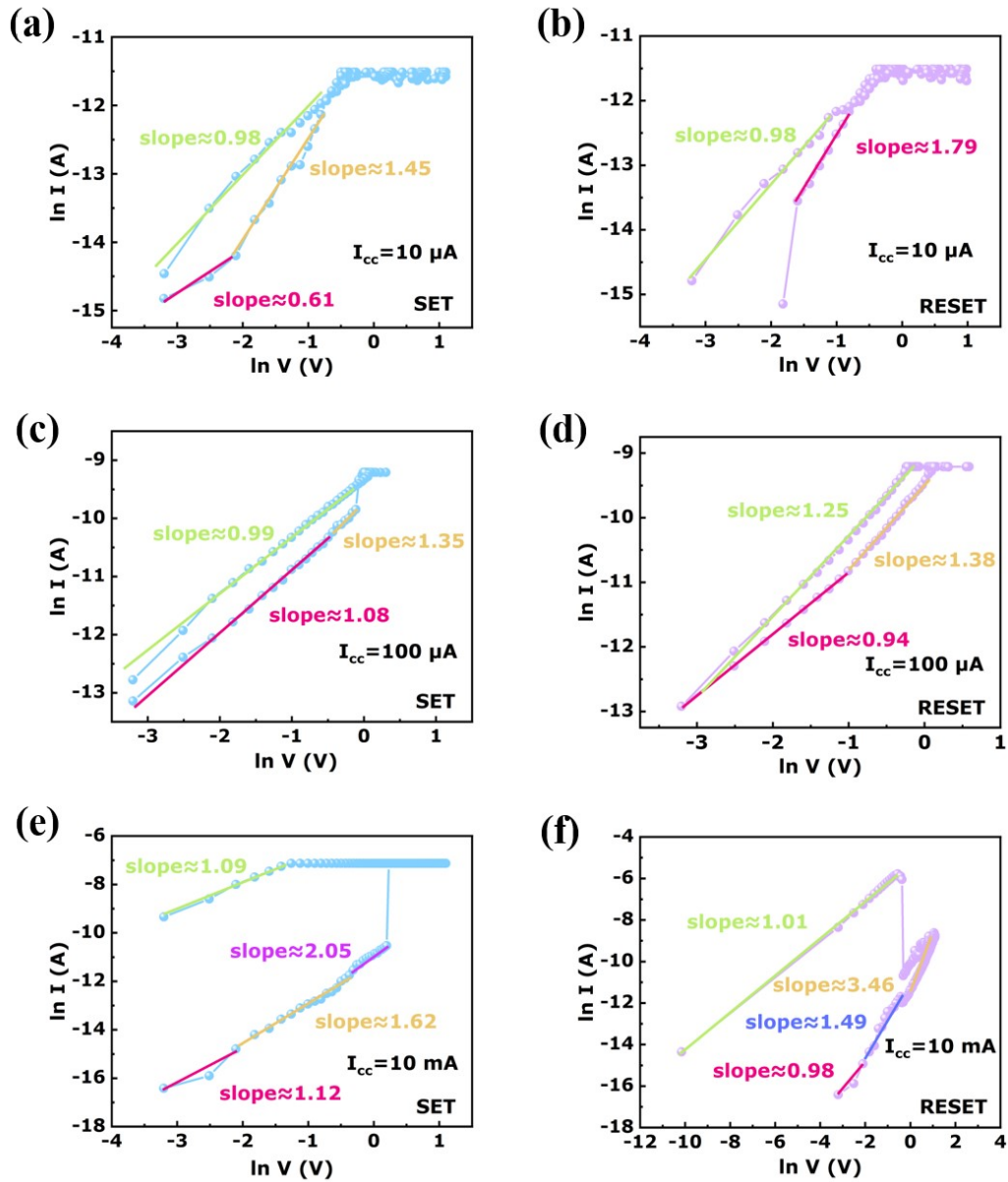


Fig. S6 The Double logarithmic plots of current and voltage for I-V curves of Al/1T MoS₂/CoS₂-SA/ITO/PET device with the compliance current is (a-b) 10 μA ; (c-d) 100 μA ; (e-f) 10 mA.

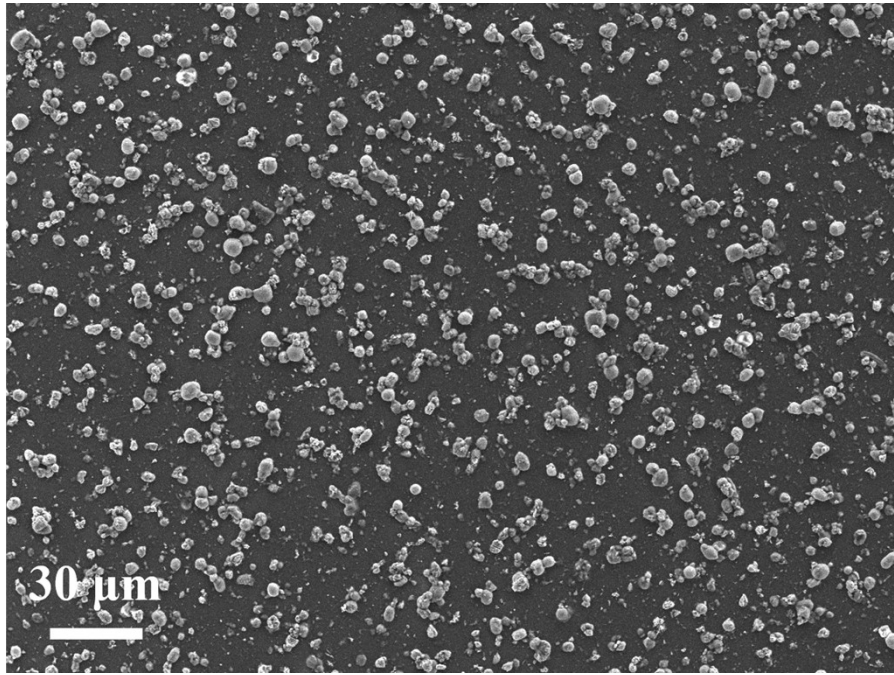


Fig. 7 The SEM image of Al/1T MoS₂/CoS₂-SA/ITO/PET device surface.

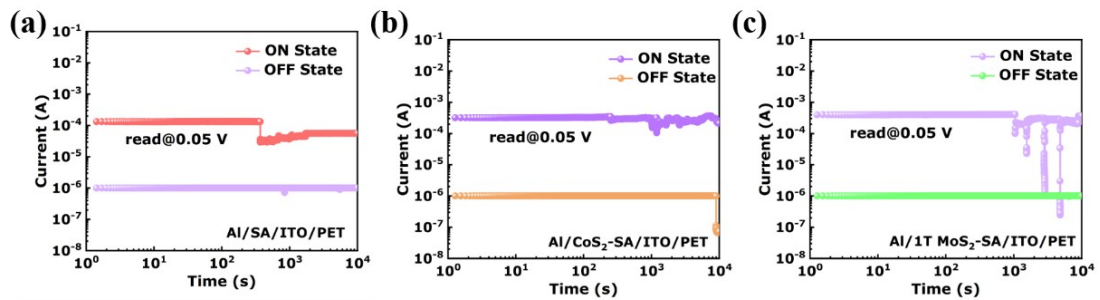


Fig. S8 The I-t diagram of (a) Al/SA/ITO/PET, (b) Al/CoS₂-SA/ITO/PET and (c) Al/1T MoS₂-SA/ITO/PET device at a read voltage of 0.05 V.

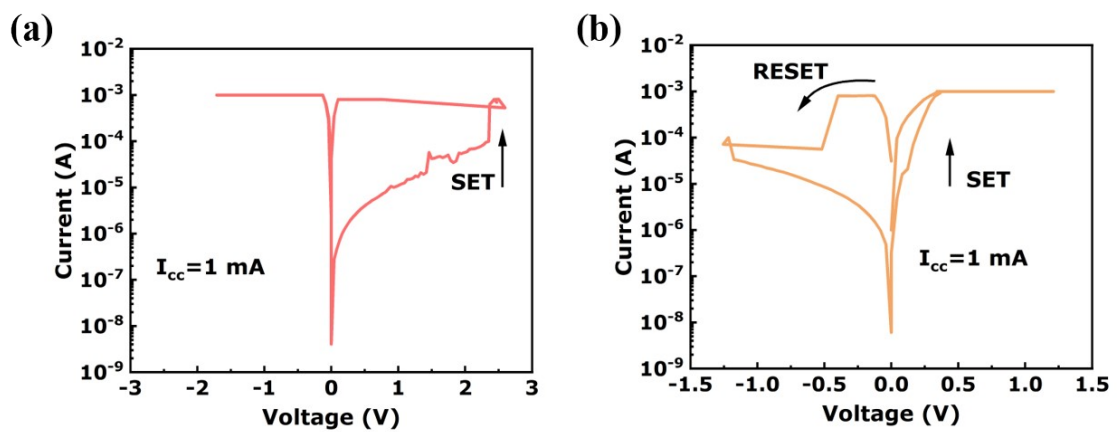


Fig. S9 I-V diagram of Al/1T MoS₂/CoS₂-SA/ITO/PET device coated with two layers.

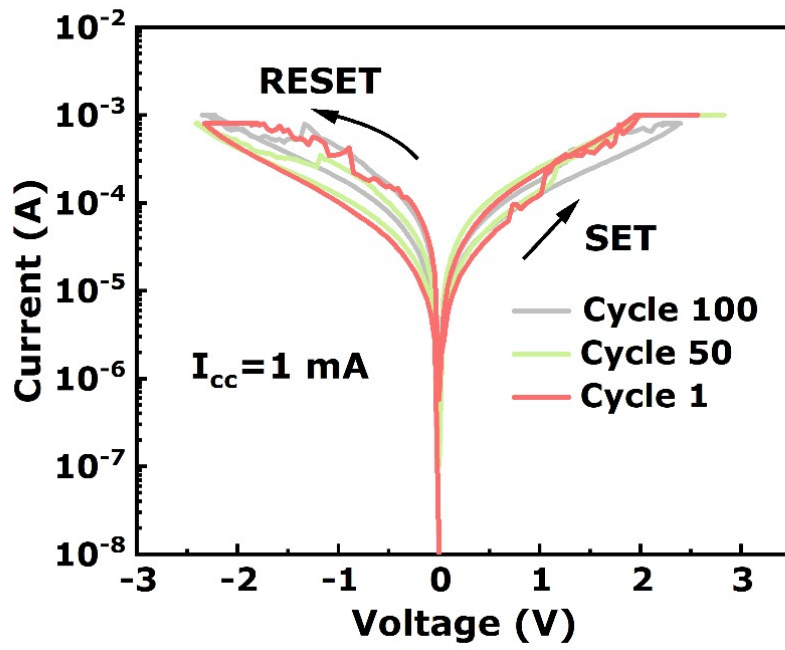


Fig. S10 I-V diagram of Al/1T MoS₂/CoS₂-SA/ITO/PET device coated with three layers.

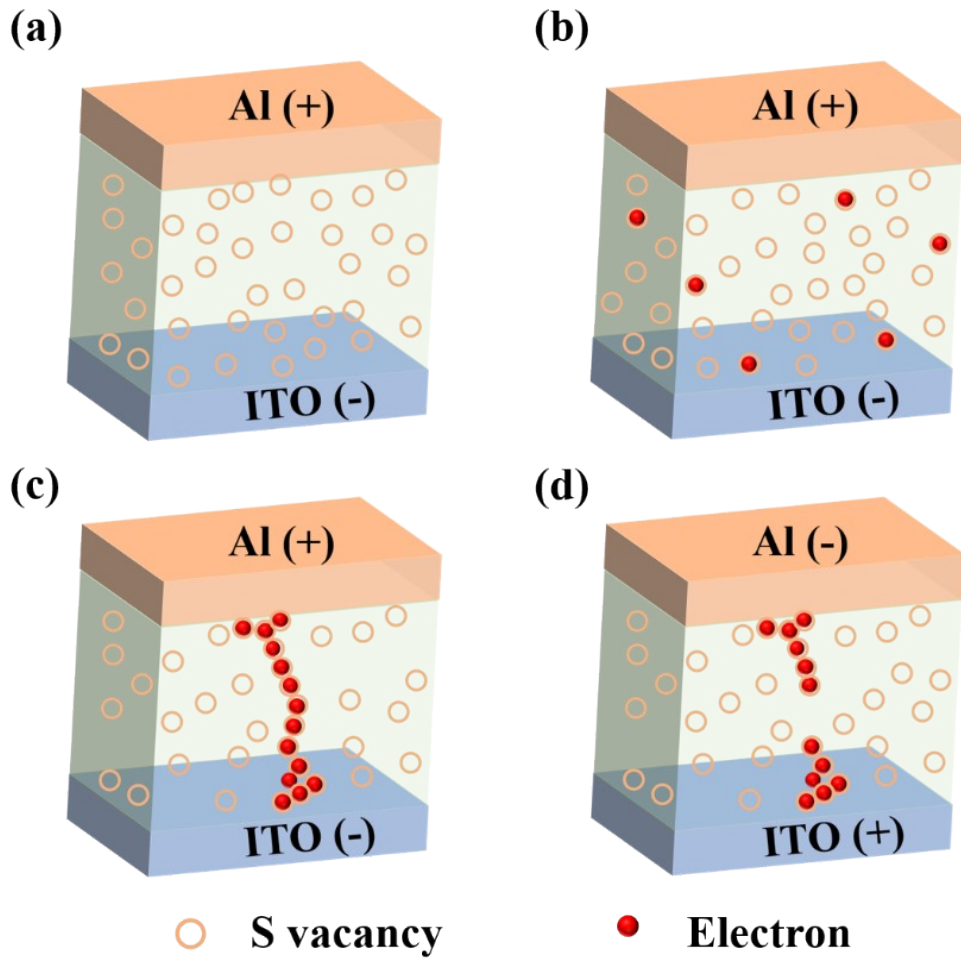


Fig. S11 Schematic diagram of switching mechanism in Al/CoS₂-SA/ITO/PET device.

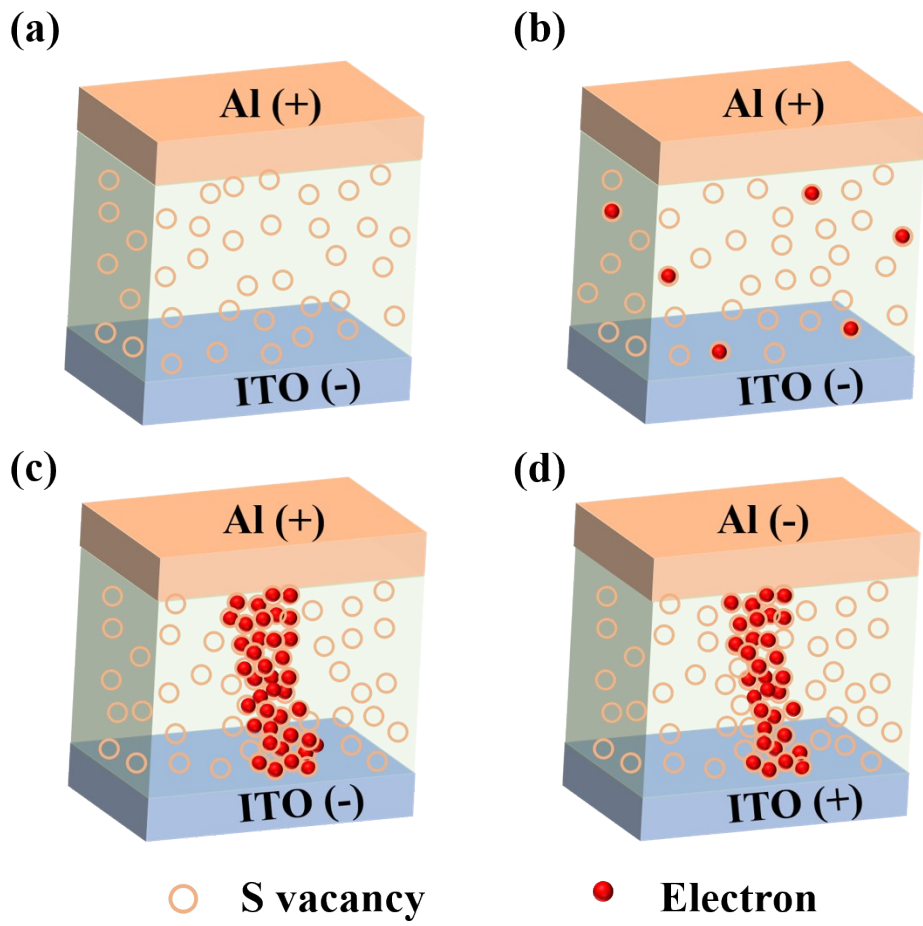


Fig. S12 Schematic diagram of switching mechanism in Al/IT MoS₂-SA/ITO/PET device.

Table S1. Comparison of the key performance parameters of MoS₂-based flexible RRAM devices.

Structures	V _{reset} /V _{set} (V)	Endurance cycles	Retention time (s)	Referen ce
Al/1T MoS ₂ /CoS ₂ -SA/ITO/PET	-1.73/1.7	100	10 ⁴	This work
Au/MoS ₂ /Au	-0.9/2.7	20	10 ⁴	[1]
Ag/MoS ₂ /Ti/Au	-0.4/0.3	350	10 ⁴	[2]
Ag/PVP: MoS ₂ /HfO _x /ITO	-1.18/2.1	500	10 ⁴	[3]
Ag/MoS ₂ /polymer/Cr/Au	-0.7/0.5	300	10 ³	[4]
Ti/Au/MoS ₂ /PDMS	-15/15	100	10 ³	[5]
Al/MoS ₂ -PDA-PFMMA/ITO	-0.9/1.1	60	10 ⁴	[6]
ITO/(MoS ₂ :PS)/Al	-2.5/2.7	25	400	[7]
Cu/gMoS ₂ -PMMA/ITO	1.3/-1.2	100	10 ⁴	[8]
Ti/MoS ₂ -rGO/ITO	-0.48/0.5	200	10 ⁴	[9]
Ag/MoS ₂ /Au/Ti/PET	-0.8/1.1	90	10 ⁴	[10]

References

- 1 S. Bhattacharjee, E. Caruso, N. McEvoy, C. Ó Coileáin, K. O'Neill, L. Ansari, G. S. Duesberg, R. Nagle, K. Cherkaoui, F. Gity and P. K. Hurley, *ACS Appl. Mater. Interfaces*, 2020, **12**, 6022–6029.
- 2 A. Bala, A. Sen, J. Shim, S. Gandla and S. Kim, *ACS Nano*, 2023, **17**, 13784–13791.
- 3 I. Varun, A. K. Mahato, V. Raghuvanshi and S. P. Tiwari, *IEEE Trans. Electron Devices*, 2020, **67**, 3472–3477.
- 4 J. Chai, S. Tong, C. Li, C. Manzano, B. Li, Y. Liu, M. Lin, L. Wong, J. Cheng, J. Wu, A. Lau, Q. Xie, S. J. Pennycook, H. Medina, M. Yang, S. Wang and D. Chi, *Adv. Mater.*, 2020, **32**, 2002704.
- 5 E. Lee, J. Kim, S. Bhoyate, K. Cho and W. Choi, *Chem. Mater.*, 2020, **32**, 10447–10455.
- 6 Yan, Q., Fan, F., Zhang, B., Liu, G., & Chen, Y., *European Polymer Journal*, 2022, **174**, 111316.
- 7 L. T. Manamel, S. C. Madam, S. Sagar and B. C. Das, *Nanotechnology*, 2021, **32**, 35LT02.

- 8 S. Bhattacharjee, U. Das, P. K. Sarkar and A. Roy, *Organic Electronics*, 2018, **58**, 145–152.
- 9 L. Wu, J. Guo, W. Zhong, W. Zhang, X. Kang, W. Chen and Y. Du, *Applied Surface Science*, 2019, **463**, 947–952.
- 10 R. M. Pallares, X. Su, S. H. Lim and N. T. K. Thanh, *J. Mater. Chem. C*, 2016, **4**, 53–61.